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4/17/03
VS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/755,673
Filing Date 1/5/2001
Inventor Forbes et al.
Assignee Micron Technology, Inc.
Group Art Unit 2823
Examiner Nguyen, K.D.
Attorney's Docket No. MI22-1531
Title: Methods of Forming Capacitor Structures, and Capacitor Structures

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References –See Attached Form PTO-1449

The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449, copies of which are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of the referenced art is respectfully requested.

Respectfully submitted,

Dated: 4/3/03

By: 

Robert C. Hyta
Reg. No. 46,791

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